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FOR IMMEDIATE RELEASE

ISSYS & KEM Sign Partnership Contract for ISSYS' Micro Density Meter Products & Develop DMFC Sensors

Integrated Sensing Systems, Inc. (ISSYS) in Ypsilanti, Michigan, announced today that it has signed a partnership contract for ISSYS' Micro Density Meter products with KEM – Kyoto Electronics Manufacturing Company, of Kyoto, Japan <http://www.kyoto-kem.com/top.html>. The ISSYS Micro Density Meter products are based on Micro ElectroMechanical System (MEMS) technology. Dr. Douglas Sparks, ISSYS' Executive Vice President, stated that “this microfluidic technology offers advantages in system and sample size, cost and reliability over current approaches to fluidic density and chemical concentration measurement.”

Dr. Yoichi Ueda, KEM's President, stated that “We have endeavored, as a specialized manufacturer of analytical instruments over 45 years, to enhance R&D, new applications and diverse post-sale support for customer satisfaction. We are now aware that there exists an increasing demand for more user-friendly, compact and precise devices with less measuring time. MEMS is an indispensable technology that fills the recent need for this solution, so it was of prime importance for us to tie up with ISSYS in order to realize our global strategy.”

Dr. Nader Najafi, ISSYS' President and CEO, stated that “it was of paramount importance for us to sign with a strategic partner that has a great reputation, proven track record, international distribution channels, and a great drive for capturing the existing markets and generating new ones. ISSYS is proud to work with a company like KEM and we are looking forward to a very productive collaboration. The combination of ISSYS' technology with KEM's sales, application and distribution expertise in analytical instruments, including density meters, will greatly expand the reach of this new technology world-wide. Already in use by the pharmaceutical, petrochemical and aviation fields, this partnership will open up new applications for fluid testing and sensing using MEMS technology.”

Company Background: ISSYS is a leader in advanced micromachining technologies for medical devices, microfluidic and scientific analytical sensing applications. Founded in 1995 by world-renowned leaders in MEMS technology, ISSYS is one of the oldest independent MEMS companies in the US and has been offering MEMS services longer than any other company in the US. ISSYS operates a “full manufacturing under one roof,” multi-million-dollar, state-of-the-

art MEMS fabrication facility located near Ann Arbor, Michigan. An ISO 9000:2001 certified organization, ISSYS is a vertically integrated company dedicated to developing and manufacturing system-level products based on MEMS technology (MEMS Inside). For more company, product and service information, please visit <http://www.mems-issys.com/>

Kyoto Electronics Manufacturing, Co. Ltd ("KEM") has endeavored as a specialized manufacturer of scientific instruments since 1961 introducing a broad product line of analyzers of high quality and reliability including Analytical and Measuring Instruments that addressed laboratory needs of the time and Continuous Monitoring System that has met ever demanding environmental protection. Headquartered in Kyoto, Japan, KEM has a world-wide network of sales offices and distributors. For more company and product information, please visit <http://www.kyoto-kem.com/top.html>.

Source: Integrated Sensing Systems, Inc. (ISSYS)

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